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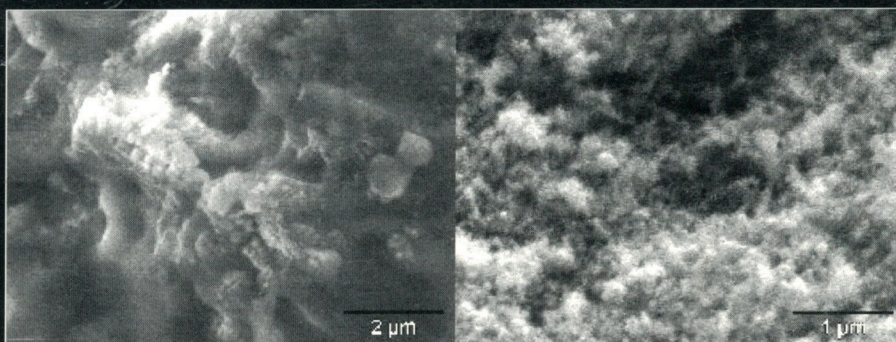
Plasma display panels: physics, recent developments and key issues

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